

English Session List

English presentations are scheduled in the following sessions.

6.4 New thin-film materials		
March 19 (Wed.) 9:00am~6:30pm	Oral Session	D6 (D Bldg. 2F-209)
March 20 (Thu.) 1:00pm~3:00pm	Oral Session	D6 (D Bldg. 2F-209)
10.1 Creation of new materials		
March 17 (Mon.) 10:00am~10:25am	Short Oral Presentations	E7 (E Bldg. 2F-201)
March 17 (Mon.) 1:30pm~3:30pm	Poster Session	PA (Arena)
March 17 (Mon.) 3:45pm~5:30pm	Oral Session	E7 (E Bldg. 2F-201)
March 18 (Tue.) 9:00am~11:45am	Oral Session	E7 (E Bldg. 2F-201)
10.2 Spin torque, spin current, circuits, and measurement technologies		
March 17 (Mon.) 10:26am~11:06am	Short Oral Presentations	E7 (E Bldg. 2F-201)
March 17 (Mon.) 1:30pm~3:30pm	Poster Session	PA (Arena)
March 19 (Wed.) 9:00am~2:00pm	Oral Session	E7 (E Bldg. 2F-201)
10.3 Giant magnetoresistance (GMR), tunnel magnetoresistance (TMR) and magnetic recording technologies		
March 17 (Mon.) 11:06am~11:18am	Short Oral Presentations	E7 (E Bldg. 2F-201)
March 17 (Mon.) 1:30pm~3:30pm	Poster Session	PA (Arena)
March 20 (Thu.) 9:00am~3:00pm	Oral Session	E7 (E Bldg. 2F-201)
10.4 Semiconductors, organic, optical, and quantum spintronics		
March 17 (Mon.) 11:18am~11:52am	Short Oral Presentations	E7 (E Bldg. 2F-201)
March 17 (Mon.) 1:30pm~3:30pm	Poster Session	PA (Arena)
March 19 (Wed.) 2:00pm~6:30pm	Oral Session	E7 (E Bldg. 2F-201)
13.5 Si-English Session		
March 19 (Wed.) 4:00pm~6:00pm	Poster Session	PG (G Bldg. 2F)
March 20 (Thu.) 9:00am~12:30pm	Oral Session	F10 (F Bldg. 406)
Symposium "Flexible Electronics"		
March 18 (Tue.) 9:00am~4:30pm	Oral Session	D9 (D Bldg. 3F-315)
Symposium "Developments and Challenges for Resistance Change Memories Technology"		
March 18 (Tue.) 9:00am~6:30pm	Oral Session	E1 (E Bldg. 1F-101)